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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **Mamoru NAKASUJI et al.**

Group Art Unit: **2881**

Serial No.: **09/891,511**

Examiner: **Jack I. Berman**

Filed: **June 27, 2001**

Confirmation No.: **8779**

For: **INSPECTION SYSTEM BY CHARGED PARTICLE BEAM AND  
METHOD OF MANUFACTURING DEVICES USING THE SYSTEM**

Attorney Docket Number: **010819**

Customer Number: **38834**

**AMENDMENT AFTER FINAL**

**MAILSTOP: AF**

Commissioner for Patents  
P. O. Box 1450  
Alexandria, VA 22313-1450

Date: July 14, 2005

Sir:

This paper is filed in response to the Office Action dated April 14, 2005.

**Amendments to the Claims** are reflected in the listing of claims that begins on page 2 of  
this paper.

**Remarks/Arguments** begin on page 28 of this paper.